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| | | Application Number | 10/602,716-Conf. #9955 | | |
| | | Filing Date | June 25, 2003 | | |
| | | First Named Inventor | Chandra Mouli | | |
| | | Art Unit | 2811 | | |
| | | Examiner Name | D. Kang Colleen Matthews | | |
| Sheet | 1 | of | 1 | Attorney Docket Number | M4065.0904/P904 |

| U.S. PATENT DOCUMENTS | | | | | |
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| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
| | | Number-Kind Code ² (if known) | | | |
| CAM | AA | 2002/0190287 | 12/19/2002 | Mann et al. | |

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| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | Publication Date | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | Y ⁶ |
| | | Country Code ³ -Number ⁴ -Kind Code ⁵ (if known) | MM-DD-YYYY | | | |
| CAM | BA | EP 0 798 785 | 10/01/1997 | | | |
| CAM | BB | JP 01-232765 | 09/18/1989 | | | X |

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| NON PATENT LITERATURE DOCUMENTS | | | | | |
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| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | | | Y ² |
| CAM | CA | Kim, K.T. et al. – "Tungsten Silicide/Titanium Nitride Compound Gate," June 4, 1990, Symposium on VLSI Technology, Honolulu, June 4-7, 1990, New York, IEEE, US, pgs 115-116. | | | |
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| CAM | CC | Ponomarev, Y.V. et al. – "Gate-Workfunction Engineering Using Poly-(Si,Ge) for High-Performance 0.18 μ m CMOS Technology," International Electron Devices Meeting 1997, IEDM Technical Digest, Washington, DC, Dec. 7-10, 1997, New York, NY, IEEE, US, 12/7/1997, pgs. 829-832. | | | |
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| Examiner Signature | Colleen Matthews | Date Considered | 12/30/2007 |
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